

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: William J. Schaff et al.

Title: METHOD OF FORMING AN ALN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR

Docket No.: 1153.044US1
Filed: May 15, 2001
Examiner: Khanh Duong
Customer No.: 21186

Serial No.: 09/858,337
Due Date: October 13, 2009
Group Art Unit: 2822
Confirmation No.: 1100

Notice of Allowance Date: July 13, 2009

Mail Stop Issue Fee

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

We are transmitting herewith the following:

- ☒ Issue Fee Transmittal (Form PTOL-85).
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- ☒ Authorization to charge Deposit 19-0743 in the amount of \$755.00 to cover the Small Entity Issue Fee Payment.
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SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 12 day of October, 2009.

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